## IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Kenji TAKASE Conf.:

Appl. No.: NEW Group:

Filed: March 4, 2004 Examiner:

For: SEMICONDUCTOR DEVICE AND MANUFACTURING

METHOD FOR SAME

## FIRST PRELIMINARY AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

March 4, 2004

## Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application.

This amendment includes: Amendments to the Claims and Remarks.